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		8543-004-27 CIP	08/825,360
		APPLICANT Marvin LIAO, et al.	
LIST OF REFERENCES CITED BY APPLICANT (Use Several Sheets if Necessary)		FILING DATE March 28, 1997	GROUP ART UNIT 2814

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
TLI	AA	4,173,661	11/1979	Bourdon			
	AB	4,420,498	12/1983	Hirose, et al.			
	AC	4,486,462	12/1984	Asahi, et al.			
	AD	4,965,090	10/1990	Gärtner, et al.			
	AE	5,017,403	5/1991	Pang, et al.			
	AF	5,314,603	5/1994	Sugiyama, et al.			
	AG	5,480,684	1/1996	Sandhu			
	AH	5,518,936	5/1996	Yamamoto, et al.			
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	AM	5,754,390	5/1998	Sandhu, et al.			
	AN	5,773,363	6/1998	Derderian, et al.			
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## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO	
TLI	AP	EP0397131 A2	11/1990	Europe	X	
	AQ	EP0711846 A1	5/1996	Europe	X	
	AR	JP63-229814	9/1988	Japan		X**
	AS	JP3-135018	6/1991	Japan		X**
	AT	JP4-100221	4/1992	Japan		X**
TLI	AU	JP6-120152	4/1994	Japan		X**

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

TLI	AV	Wang, C.K., et al., "Optimization of PVD Ti/CVD TiN Liner for 0.35 $\mu$ m Tungsten Plug Technology", Mat. Res. Society Symp. Proc., Vol. 427, p. 383-387 (1996).
EXAMINER		T. Rucaly
		DATE CONSIDERED 10/20/03

\*EXAMINER: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

\*\*English Abstract Provided